

Docket No. 51200

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: J. Cameron et al.

SERIAL NO. 10/717,975

GROUP: 1752

FILED: November 20, 2003

EXAMINER: A. Walke

FOR: MULTILAYER PHOTORESIST SYSTEMS

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AMENDMENT

Applicants file a Request for Continued Examination (RCE) herewith. Please amend the above-identified application as follows.

A listing of pending claims begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

BOS2 673490.1